



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Gas-Assisted Rapid Thermal Processing
Serial No.: 10/005,827 Filing Date: November 8, 2001
Examiner: Michael M. Trinh Group Art Unit: 2822
Docket No.: M-11914 US

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COMMISSIONER FOR PATENTS
Washington, D. C. 20231

Irvine, California
April 28, 2003
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INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant(s) wish to call the following documents (copies enclosed) to the attention of the Examiner. The documents were cited in the PCT Search Report for the corresponding PCT Application No. PCT/US02/35561.

1. A PTO form 1449 listing these documents is enclosed.

The relevance of any non-English language documents cited herein is explained in the accompanying copy of the Search Report.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, or

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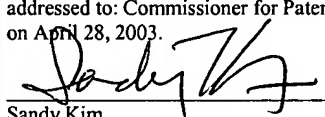
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3. an admission that the information cited herein is, or is considered to be material to patentability as defined in §1.56(b).

The undersigned hereby certifies in accordance with §1.97(e)(1) that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

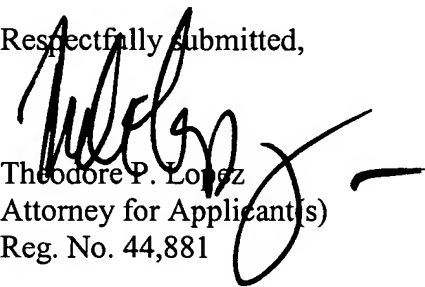
Applicant(s) believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 50-2257. Please deduct any additional fees from, or credit any overpayment to the above-noted Deposit Account.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on April 28, 2003.


Sandy Kim

April 28, 2003
Date of Signature

Respectfully submitted,


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